504702454 12/22/2017

PATENT ASSIGNMENT COVER SHEET

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	SUBMISSION TYPE:	NEW ASSIGNMENT
ı	NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
NINA WOJTAS	12/19/2017

RECEIVING PARTY DATA

Name:	MICROGAUGE AG
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Internal Address:	TANNENSTR. 3, CLA G 3
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PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	15739517

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ATTORNEY DOCKET NUMBER:	1046-0015 / 67616
NAME OF SUBMITTER:	MARK R. BILAK
SIGNATURE:	/Mark R. Bilak, Reg. No. 47,423/
DATE SIGNED:	12/22/2017

Total Attachments: 1

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PATENT REEL: 044473 FRAME: 0014 504702454

Attorney Docket Number: 1046-0015 / 67616

ASSIGNMENT

For good and valuable consideration, I,

Nina Wojtas, a citizen of Switzerland, residing at Münchhaldenstr. 9, 8008 Zürich, Switzerland;

hereinafter collectively referred to as "Assignor";

hereby sell, assign and transfer to microGauge AG having its principal place of business at c/o ETH Zürich, Professur für Mikro- und Nanosysteme, Tannenstr. 3, CLA G 3, 8092 Zürich, Switzerland hereinafter "Assignee", its successors, assigns and legal representatives, the entire right, title and interest in and for the United States and all foreign countries, in and to any and all improvements which are disclosed in the application for United States Letters Patent, which has been executed by the undersigned and

filed on 24 June 2016

as PCT International application No. PCT/EP2016/064750

entitled:

MEMS Depostion Trap for Vacuum Transducer Protection

and in and to said application and all divisional, continuing, substitute, renewal, reissue, and all other applications for Letters Patent which have been or shall be filed in the United States and all foreign countries on any of said improvements; and in and to all original and reissued patents which have been or shall be filed in the United States and all foreign countries on said improvements;

Agree that said Assignee may apply for and receive Letters Patent for said improvements in its own name; and that, when requested, without charge to but at the expense of said Assignee, its successors, assigns and legal representatives, to carry out in good faith the intent and purpose of this assignment, the undersigned will execute all divisional, continuing, substitute, renewal, reissue, and all other patent applications on any and all said improvements; execute all rightful oaths, assignments, powers of attorney and other papers; communicate to said Assignee, its successors, assigns, and legal representatives, all facts known to the undersigned relating to said improvements and the history thereof; and generally do everything possible which said Assignee, its successors, assigns or legal representatives shall consider desirable for aiding in securing and maintaining proper patent protection for said improvements and for vesting title to said improvements and all applications for patents and all patents on said improvements, in said Assignee, its successors, assigns and legal representatives; and

Covenant with said Assignee, it successors, assigns and legal representatives that no assignment, grant, mortgage, license or other agreement affecting the rights and property herein conveyed has been made to others by the undersigned, and that full right to convey the same as herein expressed is possessed by the undersigned.

RECORDED: 12/22/2017

DATE: 19.12.2017

PATENT REEL: 044473 FRAME: 0015